

REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1763

Attorney Docket: 040258-0273851
Client Reference: EL00018CDC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
KOJIMA, ET AL.

Confirmation Number: 3068

Application No.: ***09/658,501***

Group Art Unit: 1763

Filed: September 8, 2000

Examiner: Karla Moore

Title: SEMICONDUCTOR MANUFACTURING SYSTEM A VAPORIZER WHICH
EFFICIENTLY VAPORIZES A LIQUID MATERIAL

AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed July 26, 2007, the date for responding being
October 26, 2007, please amend the above-identified application as follows